

Application/Control No.	Applicant(s)/Patent under Reexamination HAN ET AL.		
10/733,990			
Examiner	Art Unit		
Khawar lobal	2617		

	SEARCHED					
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Class	Subclass	Date	Examiner			
455	69,522, 561,452.2, 67.11,424	9/7/2007	KI			
370	252,278					
	329					

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
455	561	9/7/2007	КІ	
370	252			
see sear	ch history			

SEARCH (INCLUDING SEAR)
		DATE	EXMR
John Pezzlo		8/27/2007	кі
QUOCHIEN VUONG		9/6/2007	KI
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